

| | Type | L # | Hits | Search Text | DBs | Time Stamp |
|----|------|-----|-------|--|--|---------------------|
| 1 | BRS | L1 | 168 | (silicon adj oxide) near10 (etch adj stop adj layer) | USPAT | 2002/07/29 15:29 |
| 2 | BRS | L2 | 4 | (silicon adj oxide) near10 (organosilicate) | USPAT; US-PGP UB; EPO; JPO; DERWEN T; IBM_TD B | 2002/07/29 15:31 |
| 3 | BRS | L4 | 1 | (organosilicate) same (etch adj stop adj layer) same (silicon adj oxide) | USPAT; US-PGP UB; EPO; JPO; DERWEN T; IBM_TD B | 2002/07/29 15:34 |
| 4 | BRS | L5 | 35913 | silicon adj oxide | USPAT | 2002/07/29 15:34 |
| 5 | BRS | L6 | 129 | 5 near5 (etch adj stop adj layer) | USPAT | 2002/07/29 15:43 |
| 6 | BRS | L7 | 6932 | (etch or etching) near10 (silicon adj oxide) | USPAT | 2002/07/29 15:43 |
| 7 | BRS | L8 | 2 | 7 same (organosilicate) | USPAT | 2002/07/29 16:43 |
| 8 | BRS | L9 | 2 | (organosilicate) near10 (etch or etching or etched) | USPAT | 2002/07/29 16:46 |
| 9 | BRS | L10 | 11 | organosilicate near10 temperature | USPAT | 2002/07/29 16:50 |
| 10 | BRS | L11 | 175 | (silicon adj oxide) near10 (etch or etched or etching) near10 pressure | USPAT | 2002/07/29 16:51 |
| 11 | BRS | L12 | 31 | 11 same temperature | USPAT | 2002/07/29 16:51 |